

LIST OF ART CITED BY APPLICANT

(PTO-1449)

 ATTY. DOCKET NO.
RPL-0006REI

 APPLN. SERIAL NO.
10/648,384

 APPLICANT(S)
Tae-Wan CHO and Seong-Ho KANG

 FILING DATE
August 27, 2003

 GROUP
2877

U.S. PATENT DOCUMENTS

| EXAMINER'S INITIALS | *PATENT NO. | *ISSUE DATE | *INVENTOR NAME | CLASS | SUBCLASS | FILING DATE |
|---------------------|-------------|-------------|----------------|-------|----------|-------------|
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U.S. PATENT APPLICATION PUBLICATIONS

| | *PATENT APPLN. PUB. NO. | *PUB. DATE | *APPLICANT | CLASS | SUBCLASS | |
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U.S. PATENT APPLICATIONS

| | *APPLN. NO. | *FILING DATE | *INVENTOR | CLASS | SUBCLASS | |
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FOREIGN PATENT DOCUMENTS

| EXAMINER'S INITIALS | PATENT NO. | DATE | COUNTRY | CLASS | SUBCLASS | Translation | |
|---------------------|--------------|---------|---|-------|----------|-------------|----|
| | | | | | | Yes | No |
| | JP 02-148645 | 06-1990 | Japan (Japanese Full Text and English Abstract) | | | X | |
| | JP 09-265913 | 10-1997 | Japan (Japanese Full Text and English Abstract) | | | X | |
| | JP 09-237580 | 09-1997 | Japan (Japanese Full Text and English Abstract) | | | X | |
| | JP 03-190039 | 08-1991 | Japan (Japanese Full Text and English Abstract) | | | X | |
| | JP 06-044907 | 02-1994 | Japan (Japanese Full Text and English Abstract) | | | X | |
| | JP 63-131436 | 06-1988 | Japan (Japanese Full Text and English Abstract) | | | X | |
| | JP 08-250030 | 09-1996 | Japan (Japanese Full Text and English Abstract) | | | X | |
| | JP 08-250029 | 09-1996 | Japan (Japanese Full Text and English Abstract) | | | X | |
| | JP 11-288250 | 10-1999 | Japan (Japanese Full Text and English Abstract) | | | X | |

OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

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|--|---|
| | Japanese Office Action dated December 18, 2007. |
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EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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